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PATENT & TRADEMARK OFFICE

<b>Form PTO-1449</b> <b>INFORMATION DISCLOSURE CITATION</b> <b>IN AN APPLICATION</b> <i>(Use several sheets if necessary)</i>	Docket Number 204552022500	Application Number 10/070,292
	Applicant <b>Hirokazu TANAKA et al.</b>	
	Filing Date 3-5-2002	Group Art Unit 1762
	Examiner Michael Barr	

**U.S. PATENT DOCUMENTS**

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO

**OTHER DOCUMENTS** *(including author, title, Date, Pertinent Pages, Etc.)*

Examiner Initials	Ref. No.	Title
7	1.	"Material processing with excimer lasers" H K Toushoff and T Butje / Proc. 5th Int. Conf. on Lasers in Manufacturing 35 - 43 September 1988 ( ISBN 1-85423-021-2 ).

EXAMINER: <i>Michael Barr</i>	DATE CONSIDERED: <i>4/7/04</i>
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EXAMINER: Initial if citation considered, whether or not the citation conforms with MPEP 609. Draw a line through the citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.